

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Shimizu <i>et al.</i>
App. No	:	10/618,900
Filed	:	July 14, 2003
For	:	SINGLE-WAFER-PROCESSING TYPE CVD APPARATUS
Examiner	:	Rudy Zervigon
Art Unit	:	1792
Conf #	:	7366

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action electronically sent on January 03, 2008, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Summary of Interview begins on page 5 of this paper.

Remarks/Arguments begin on page 6 of this paper.